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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Casimer M. DeCusatis, et al.

Docket: FIS920010131US1(14564)

Serial No.: Unassigned

Dated: September 20, 2001

Filed: Herewith

For: OPTICAL POWER CONTROL MONITOR
FOR MULTIPLE WAVELENGTH
FIBER-OPTIC NETWORKS

Assistant Commissioner for Patents
Washington, DC 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to 37 C.F.R. §§1.56, 1.97 and 1.98, applicants submit the following references which applicants believe may be material to the above-identified patent application. A copy of the references which applicants wish to make of record in this case is enclosed herein for the Examiner's convenience along with a listing on Form PTO-1449 attached.

1. Bann, R., et al., "Micromachining system accommodates large wafers," Laser Focus World, www.optoelectronics-world.com, pp. 189-192, January 2001;
2. Kartalopoulos, S., "INTRODUCTION TO DWDM TECHNOLOGY Data in a Rainbow," IEEE, Chapter 3, pp. 67-68, (1999); and


CERTIFICATE OF MAILING BY "EXPRESS MAIL"

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I hereby certify that this correspondence is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 C.F.R. §1.10 on the date indicated above and is addressed to the Assistant Commissioner of Patents and Trademarks, Washington, D.C. 20231.

Dated: October 12, 2001



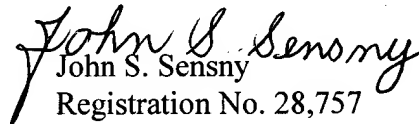
Karen Cing-Mars
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3. Carroll, J., et al., "Distributed feedback semiconductor lasers," IEEE Circuits, Devices and Systems Series 10, SPIE Press Monograph, Vol. PM52, pp 9-15, (1998).

All the references listed on Form PTO-1449 are in the English language, thus, a concise explanation of those references required by 37 C.F.R. §1.98(a)(3) is not necessary.

This Information Disclosure Statement is being submitted with the filing of this application; thus no fee or certification under 37 C.F.R. §1.97(e) is required.

Respectfully submitted,


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INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)

FIS920010131US1(1)

Application Number

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Applicant(s)

Casimer M. DeCusatis, et al.

Filing Date

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Group Art Unit

Unassigned

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*EXAMINER
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Bann, R., et al., "Micromachining system accommodates large wafers," Laser Focus World, www.optoelectronics-world.com, pp. 189-192, January 2001

Kartalopoulos, S., "INTRODUCTION TO DWDM TECHNOLOGY Data in a Rainbow," IEEE, Chapter 3, pp. 67-68, (1999)

Carroll, J., et al., "Distributed feedback semiconductor lasers," IEE Circuits, Devices and Systems Series 10, SPIE Press Monograph, Vol. PM52, pp 9-15, (1998)

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.